



Application No.: 10/060,826
Docket No.: IB-1581 (LBNL 207)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Daniel S. Pickard et al.

Application No.: 10/060,826

Confirmation No.: 9952

Filed: February 1, 2002

Art Unit: 2821

For: MATCHING NETWORK FOR RF PLASMA
SOURCE

Examiner: W. Lee

RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Response is filed in reply to all issues raised in the Office action mailed September 20, 2005. No amendments are submitted in conjunction with this Response.

Remarks begin on page 2 of this paper.